Dynamic Offset-Cancellation Techniques

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Motivation

- Many sensors (e.g. thermopiles, bridges, hall sensors) output DC signals in the millivolt range
- These signals are best processed on-chip
- However, the offset of basic IC amplifiers is also in the millivolt range, especially in CMOS
- Therefore, special techniques are required to reduce the offset of IC amplifiers

Outline

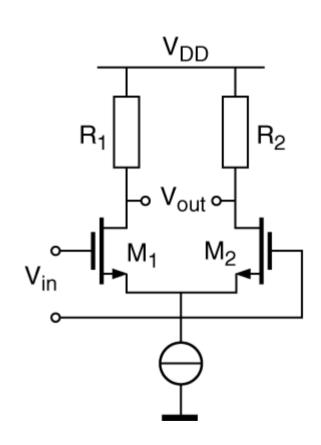
- Differential amplifiers
 - Offset and 1/f noise
- Trimming
- Dynamic Offset Cancellation
 - Auto-zeroing
 - Chopping
- Interfacing Examples
- Conclusion
- References

Differential Amplifiers

Differential amplifiers are widely used to amplify DC signals

Balanced structure is

- Nominally offset free
- Rejects common-mode and power supply interference
- Easily realized in both CMOS and bipolar technologies



Offset in Differential Amplifiers

Component mismatch \Rightarrow offset e.g. $R_1 \neq R_2$, $M_1 \neq M_2$

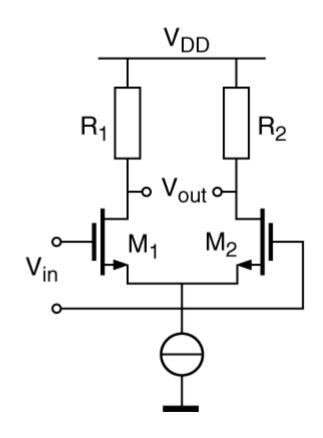
Mismatch is mainly due to

- Process variation
- Lithographic errors

All other things being equal:

Bipolar \Rightarrow $V_{os} \sim 0.1 \text{mV}$

CMOS \Rightarrow 10 -100 times worse!



Drift and Noise

Drift

- Temperature, ageing and packaging stress cause time-varying offset
- Trimming bipolar DA's reduces both offset and temperature drift [1]. Not true of MOSFETs!

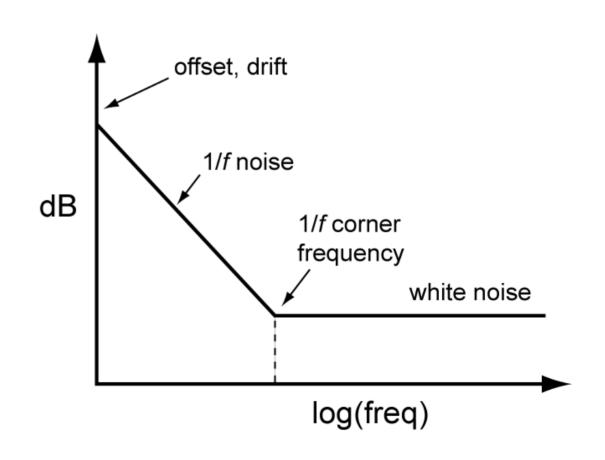
1/f (or flicker) noise

- MOSFETs are worse than bipolar transistors
- Varies inversely with transistor area

Amplifier Behaviour Near DC

Characterized by

- Offset
- Drift
- 1/*f* noise
- PSRR, CMRR



What to Do?

Offsets and 1/f noise are part of life

But we can reduce offset "enough" by

- 1. Using "large" devices and good layout [2]
- 2. Trimming (bipolar) or by
- 3. Dynamic offset-cancellation (DOC) techniques

DOC techniques also reduce 1/f noise!

Trimming

External potentiometers

Extra component and extra pins

In IC technology [3]

- Laser trimming
- Component switching
 - Zener zapping
 - Fusible links
 - o PROM

Trimming ⇒ extra test infrastructure

DOC Techniques

Auto-zeroing

Sampled data

Sample offset, then subtract

Chopping

Continuous time

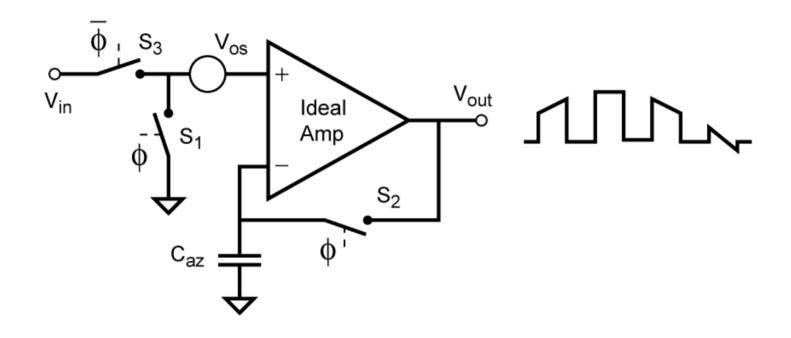
Modulate offset away from DC

Switches required ⇒ CMOS or BiCMOS

DOC Techniques Versus Trimming

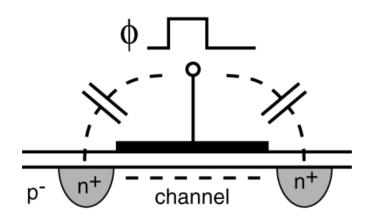
- + reduction of offset and 1/f noise
- + excellent long term stability
- + no additional costs for testing
- reduced bandwidth
- increased circuit complexity
- aliasing & intermodulation issues

Auto-zero Principle



- S1,2 closed ⇒ amplifier offset is stored on C_{az}
- S3 closed ⇒ output signal is available
- Residual offset ~ V_{os}/A

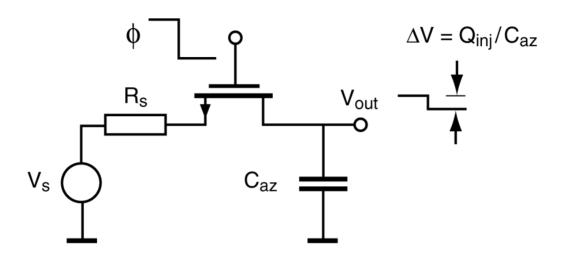
Charge Injection (1)



Occurs when MOSFETs switch **OFF**Consists of two components

- Channel charge, Q_{ch}= WLC_{ox}(V_{GS}-V_t)
- Overlap capacitance between the gate and the source/drain diffusions

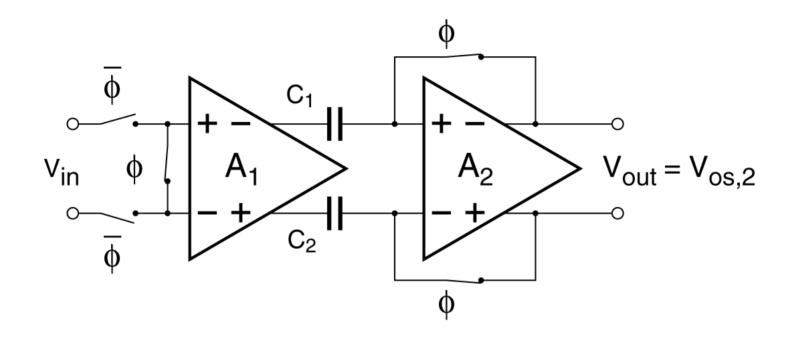
Charge Injection (2)



Error voltage depends on [4,5]

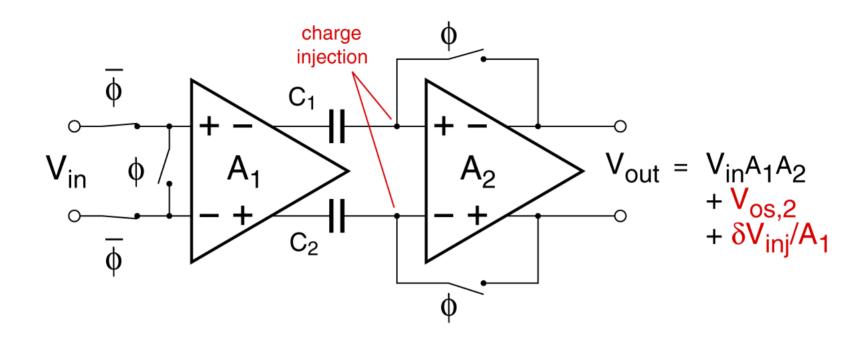
- Source impedance
- Transistor area (WL)
- Value of C_{az}
- Clock amplitude & slew rate

Switched Capacitor Amplifier (1)



During the auto-zero phase, the offset of A₁ and A₂ is stored on C_{1,2}

Switched Capacitor Amplifier (2)



- During the next phase, V_{in} is amplified
- Differential topology ⇒ 1st order cancellation of charge injection errors

Residual Offset of Auto-zeroing

Determined by

- Charge injection
- Leakage on C_{az}
- Limited amplifier gain & bandwidth (f_c)

In practice

- C_{az} as large as possible (sometimes external)
- Multi-stage amplifier topologies
- f_c >> sampling frequency f_s
- Residual offsets of 1-10μV

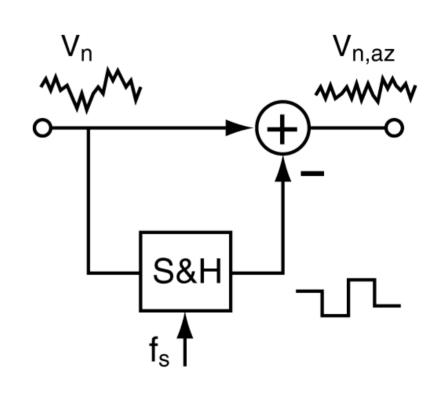
Residual Noise of Auto-zeroing (1)

$$V_{n,az}(f) = V_n(f)^*(1 - H(f))$$

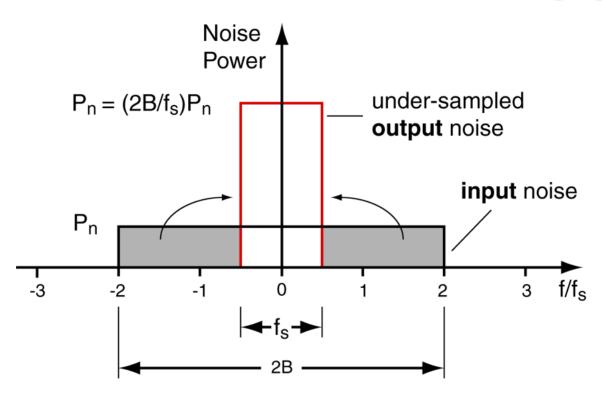
H(f) is the frequency response of the S&H

$$H(f) = sinc(f)$$

- \Rightarrow 1-H(f) is a HPF
- ⇒ Offset and 1/f noise reduction!

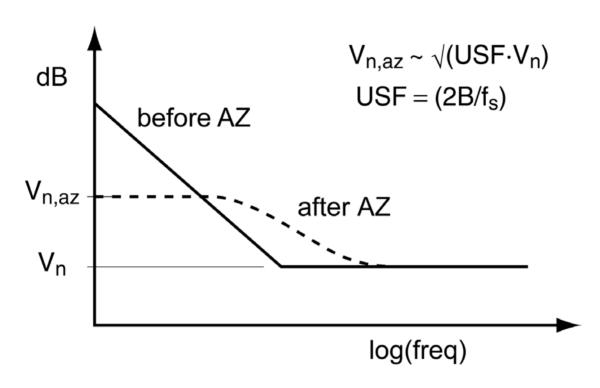


Residual Noise of Auto-zeroing (2)



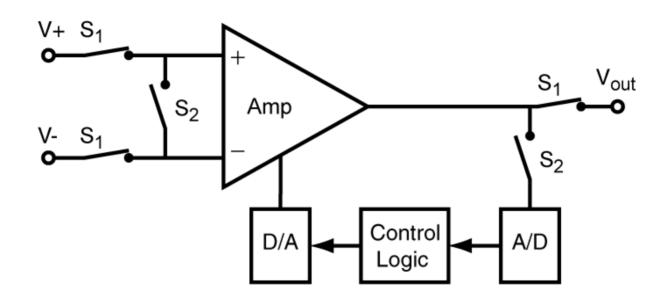
- Since noise bandwidth B > f_s ⇒ input noise is folded back to DC
- The result is LP filtered by the Hold function

Residual Noise of Auto-zeroing (3)



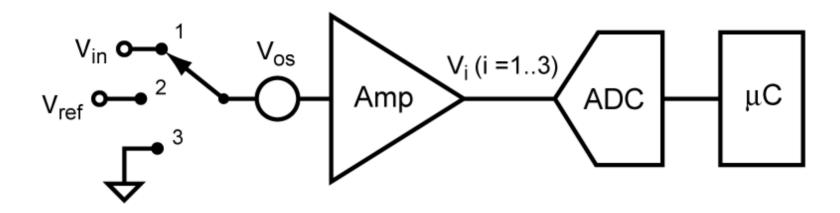
- 1/f noise is removed **but** noise foldover occurs [6]
- For a 1st order LPF, B = $\pi f_c/2$
- State of the art is 48nV/√Hz [7]

Digital Trimming



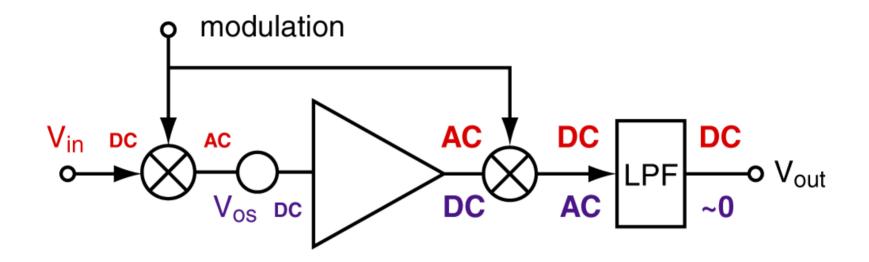
- Auto-zero at power on [8]
- No reduction of 1/f noise
- But no bandwidth limitation
- Residual offset determined by D/A resolution

The 3 Signal Method



- Phase 1: $V_1 = A(V_{os} + V_{in})$
- Phase 2: $V_2 = A(V_{os} + V_{ref})$
- Phase 3: $V_3 = AV_{os}$
- \Rightarrow A,V_{os} and V_{in} can be calculated
- Easy to implement if a µC is available

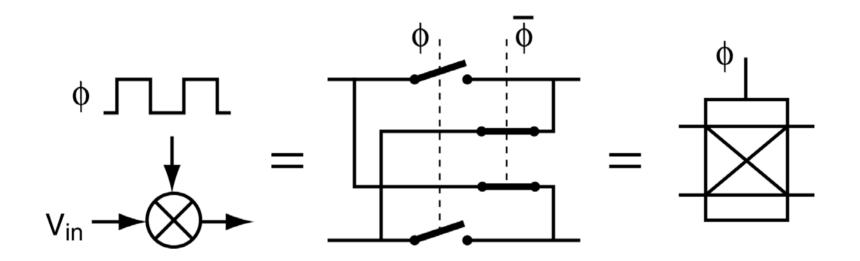
Chopping Principle



Signal is modulated, amplified and then demodulated again [9]

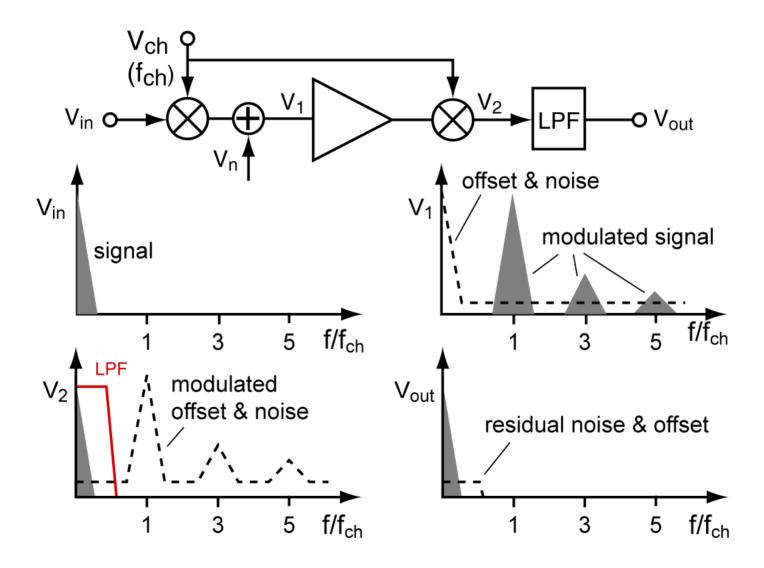
- + Output signal is continuously available
- Low-pass filter required

Square-wave Modulation

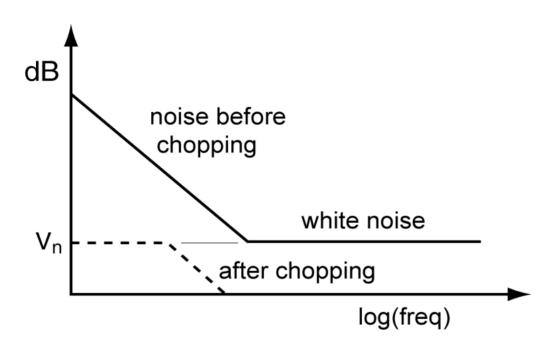


- Easily generated modulating signal
- The modulator is a polarity-reversing switch
- Switches are easily realized in CMOS

Chopping in the Frequency Domain

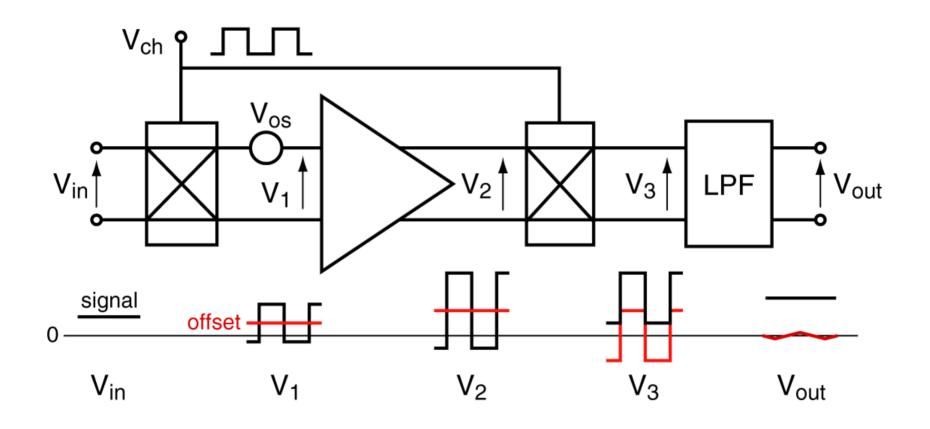


Residual Noise of Chopping



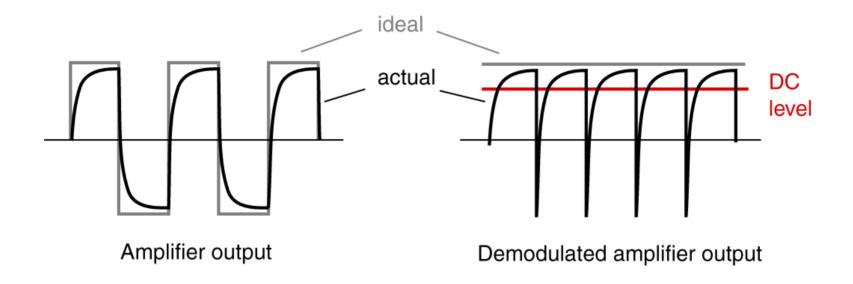
- 1/f noise is completely removed provided [6]
 f_{ch} > 1/f corner frequency
- Significantly better than auto-zeroing!
- State-of-the-art is 8.5nV/√Hz [10]

Chopping in the Time Domain



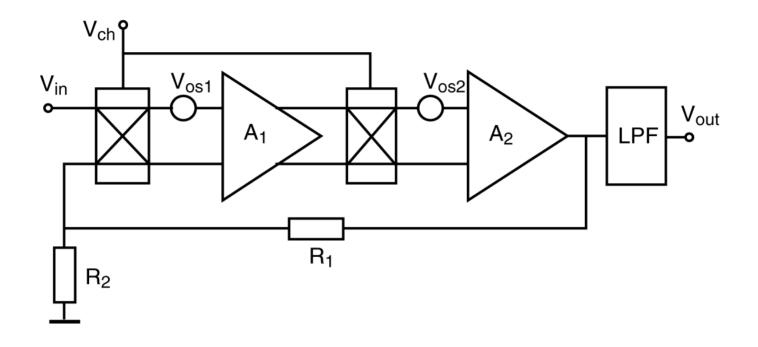
Clock duty-cycle should be exactly 50% ⇒ ÷2

Bandwidth & Gain Accuracy



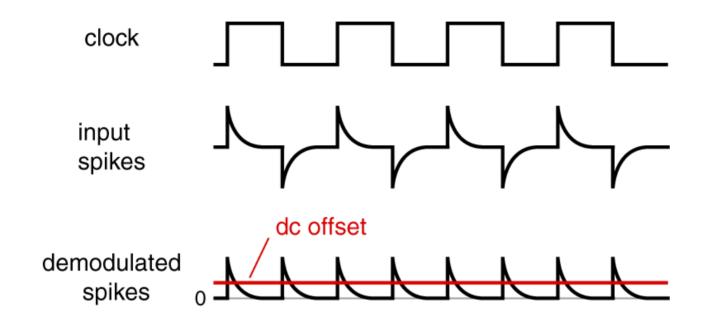
- Limited BW reduces effective gain
- $A_{eff} = A_{nom}(1-4\tau/T)$ for a 1st order LPF, where $f_{ch} = 1/(2\pi\tau)$ and $\tau << T$
- $T/\tau = 40 \Rightarrow 10\%$ error!

Chopper Opamp



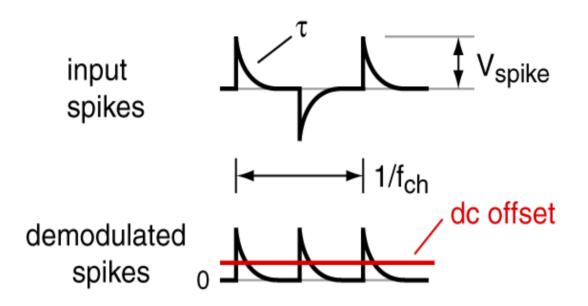
- Feedback resistors ⇒ Accurate gain [11,12]
- Offset is modulated, not the signal!
- To suppress V_{os2}, A₁ should have high gain

Residual Offset of Chopping (1)



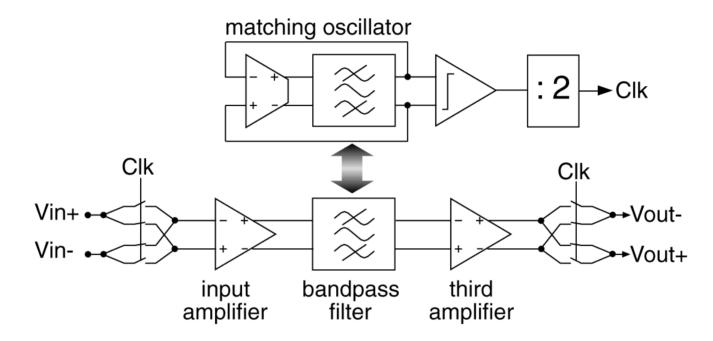
- Due to charge injection at the input chopper
- Causes a typical offset of a few μV
- Input spikes ⇒ bias current (a few tens of pA)

Residual Offset of Chopping (2)



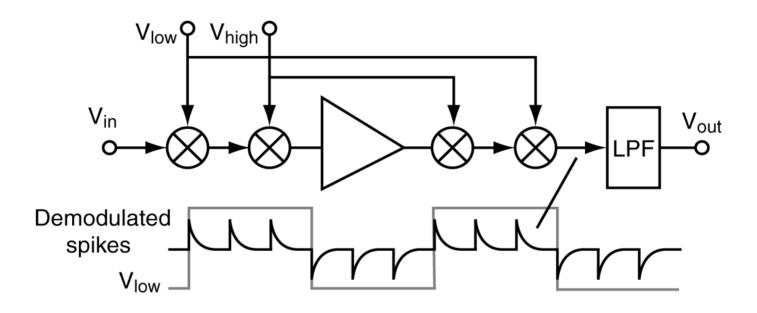
- Residual offset = $2f_{ch} V_{spike} \tau$
- Linearly dependent on chopping frequency f_s
- Spike time constant τ will vary with source impedance

Band-pass Filtering



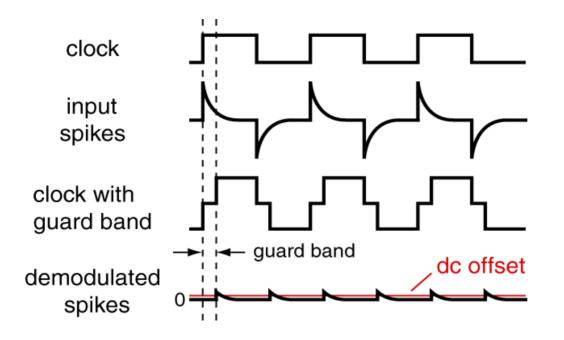
- BP (LP) filter reduces spike amplitude [10,13]
- Clock frequency tracks BP fillter's center frequency
 ⇒ low filter Q ~ 5
- Residual offset < 1μV!

Nested Chopper



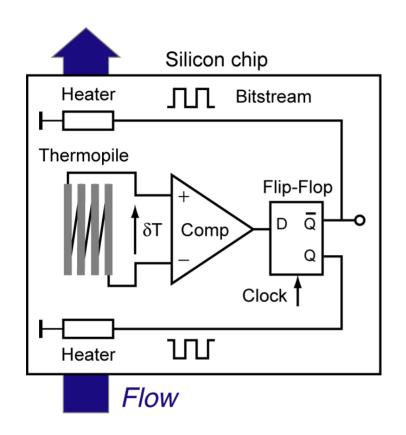
- Inner chopper removes 1/f noise
- Outer chopper removes residual offset [11,14]
- Residual offset ~ 100nV!

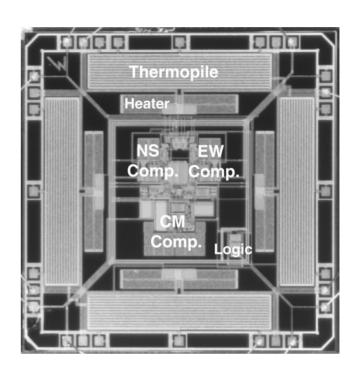
Chopper With Guard Band



- During guard-band, output is shorted [15,16] or tri-stated [17]
- Residual offset ~ 200nV!
- Slightly worse noise performance

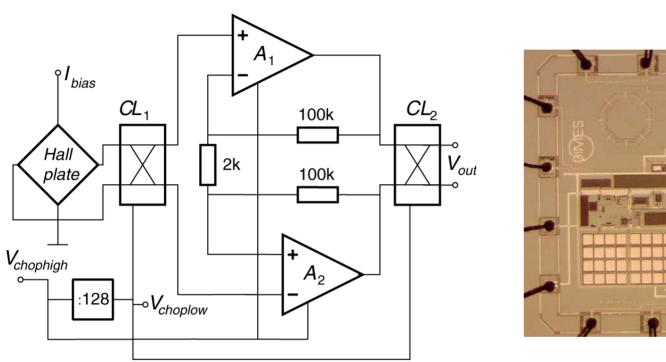
Smart Thermal Wind Sensor

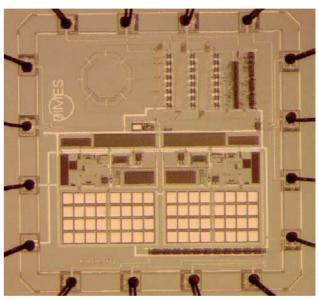




- Airflow induces a temperature gradient in chip
- Thermopiles are read-out by auto-zeroed comparators in a null-balance configuration [18]

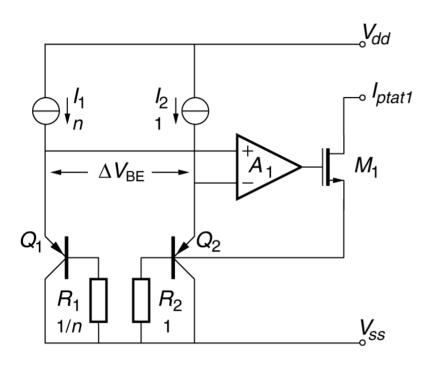
Smart Magnetic Field Sensor

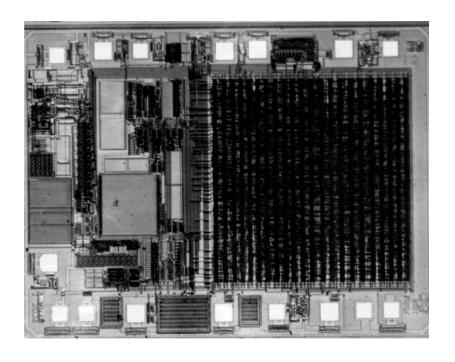




- Hall-plate is read-out using spinning-current & nested chopper techniques [19]
- Courtesy of A.Bakker, Philips Semiconductors, Delft

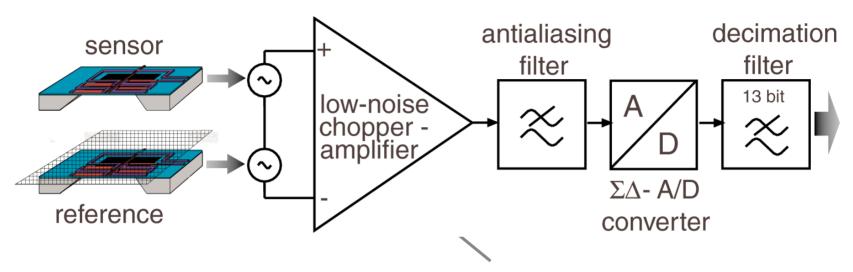
Smart Temperature Sensor



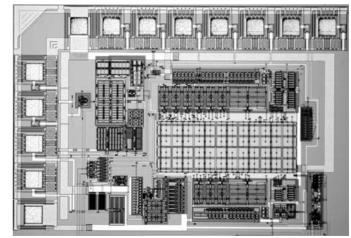


- ∆V_{be} ~ kT/q read-out using nested chopper technique
 ⇒ ±1°C uncalibrated accuracy [14,20]
- Courtesy of A.Bakker, Philips Semiconductors, Delft

Smart Calorimetric Gas Sensor



- Calorimetric sensor readout using BP chopper [21]
- Courtesy of C. Hagleitner, Physical Electronics Laboratory, ETH, Zurich



Summary

- Mismatch and offset are part of life
- Trimming reduces offset but not the noise
- Auto-zeroing only reduces LF noise, but does not limit amplifier bandwidth
- Chopping eliminates LF noise, but limits amplifier bandwidth

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